



OK TO ENTER: /AC/

1Fr AF
MAIL STOP AF
PATENT
8075-1055

IN THE U.S. PATENT AND TRADEMARK OFFICE

In re application of

Tadahiro OHMI et al. Conf. 2418

Application No. 09/889,269 Group 1794

Filed March 5, 2002 Examiner A. Chevalier

METAL MATERIAL HAVING FORMED THEREON CHROMIUM OXIDE, PASSIVE FILM AND METHOD FOR PRODUCING THE SAME, AND PARTS CONTACTING WITH FLUID AND SYSTEM FOR SUPPLYING FLUID AND EXHAUSTING GAS

RESPONSE AFTER FINAL REJECTION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

June 19, 2008

Sir:

The following is responsive to the Official Action mailed March 21, 2008.

Remarks begin on page 2 of this paper.